SHIGA7.016APC PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :

: Hada et al.

Appl. No.

: 10/535,533

Filed

: May 19, 2005

For

: METHOD OF FORMING RESIST

PATTER, POSITIVE RESIST

COMPOSITION, AND LAYERED

PRODUCT

Examiner Group Art Unit

: Chu, John S. Y. : 1752

RESPONSE TO OFFICE ACTION

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed March 9, 2007, please consider the following remarks

Remarks begin on page 2 of this paper.